



LIST OF PUBLICATIONS  
CITED BY THE APPLICANT

|                     |            |
|---------------------|------------|
| Attorney Docket No. | Serial No. |
| 0360-0033 (F7-5537) | 09/457,173 |
| Applicant           | Examiner   |
| James D. Jacobson   | Sun U. Kim |
| Filing Date         | Group      |
| December 8, 1999    | 1723       |

OTHER PUBLICATIONS

|                  |   |
|------------------|---|
| Examiner Initial | Include name the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, etc.), date, page(s), volume issue number(s), publisher city and/or country where published  |
| JK               | English abstract re Japanese Patent Application JP 03-060713 A published March 15, 1991.  |
| JK               | TRAUTMANN, C. ET AL "Pore Geometry of Etched ION Tracks in Polyimide," <i>Nuclear Instruments &amp; Methods in Physics Research, Section - B: Beam Interactions With Materials and Atoms</i> , vol. 111, no. 1, April 1, 1996, North Holland Publishing Company, Amsterdam, NL. |
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| Examiner: | <i>JKim</i> | Date Considered: | <i>9/23/04</i> |
|-----------|-------------|------------------|----------------|

\*Examiner:

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